

<b>Notice of References Cited</b>	Application/Control No. 10/783,174	Applicant(s)/Patent Under Reexamination RHODES ET AL.	
	Examiner John S. Chu	Art Unit 1752	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,790,579	09-2004	Goodall et al.	430/170
*	C	US-2002/0136982	09-2002	Goodall et al.	430/270.1
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	K	US-			
	L	US-			
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**NON-PATENT DOCUMENTS**

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